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RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2811

PATENT APPLICATION
Docket No.: 4591-227
Client Ref. No.: IE10176-US-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Do-Hyung KIM, et al.

OK to enter.

Serial No.: 10/083,756

Examiner: Hu, Shouxiang

Shu

Filed: February 25, 2002

Group Art Unit: 2811

Confirmation No.: 2262

For: METHOD FOR FORMING LAYER FOR TRENCH ISOLATION
STRUCTURE

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 20070716, dated July 26, 2007, please
amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 6 of this paper.